

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	KIKUO MAEDA ET AL.)
) Group Art Unit: 1792
Serial No.:	10/807,774)
) Examiner: Crowell, Anna M
Filed:	March 23, 2004)
) Confirmation No. 4282
For:	THIN FILM FORMING APPARATUS)
	AND THIN FILM FORMING METHOD)

Customer No.: 23413

RESPONSE TO RESTRICTION REQUIREMENT

Via EFS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement mailed February 6, 2008, Applicant submits the following response.